



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/736,999

Filed: December 16, 2003

Inventor(s):

Gavriela D. Lavie and
Shiri Kerman-Hendell

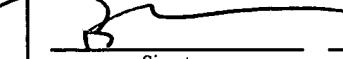
Title: CAUSE TO EFFECT
METHODOLOGY FOR
MONITORING
DATABASE
PERFORMANCE

§ Examiner: 5760-14800
§ Group/Art Unit: Rayyan, Susan F.
§ Atty. Dkt. No: 2167

§
§ I hereby certify that this correspondence is being deposited with
§ the United States Postal Service with sufficient postage as first
§ class mail in an envelope addressed to Commissioner for
§ Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the
§ date indicated below.

B. Noël Kivlin

Printed Name

 April 21, 2008

Signature

Date

RESPONSE TO OFFICE ACTION MAILED DECEMBER 20, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This paper is submitted in response to the Office Action of December 20, 2007, to further highlight why the application is in condition for allowance.

Please amend the case as listed below.